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PATENT  
29926/38060



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Sung-Kwon Lee and )  
Sang-Ik Kim )

Serial No.: 10/066,849 )

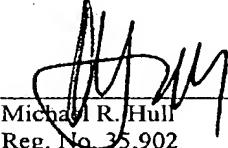
Filed: February 4, 2002 )

For: Method for Manufacturing Multi- )  
Level Interconnections with Dual )  
Damascene Process )

Group Art Unit: 1756 )

Examiner: John S. Ruggles )

I hereby certify that this paper and the )  
documents referred to as enclosed )  
therewith are being deposited with the )  
United States Postal Service as first class )  
mail, postage prepaid, on April 26, 2004, )  
in an envelope addressed to )  
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AMENDMENT AFTER FINAL (37 C.F.R. § 1.116)

Sir:

In response to the final office action mailed on February 25, 2004, please amend the above-identified patent application as follows.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims begin on page 4 of this paper.

Amendments to the abstract begin on page 7 of this paper.

Remarks begin on page 8 of this paper.